

A



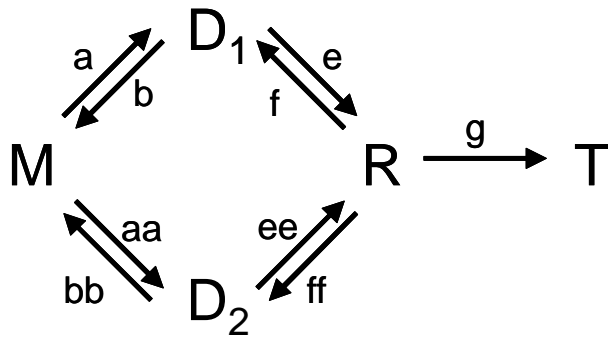
SSQ	a	b	c	d	e	f	g
0.072	1.26	47.4	16.7	1.01	1.10	0.00562	0.0834

B



SSQ	a	b	c	d	e	f	g
0.063	0.0466	0.0225	1.66	178	31	0.120	0.164

C



SSQ	a	b	aa	bb	e	f	ee	ff	g
0.0766	4.11e-6	566	0.30	10.3	0.0067	1.02e-8	0.922	0.0061	0.078

Supplemental Figure Legends

Figure S1. Best fit results for variations of the Mechanism E reassembly pathway demonstrates that including first-order conformational changes or an alternative dimerization pathway do not significantly improve the fit of Mechanism E. (A) Best fit of the concentration dependent TTR reassembly to a variation of the Mechanism E reassembly pathway with a conformational change in the monomer prior to dimerization ($M'MDRT$). The table indicates the sum of squared differences (SSQ) and the best fit rate constants with the units of $\mu M^{-1} sec^{-1}$ for all bimolecular processes and with the units of sec^{-1} for all first-order rate processes. The slight improvement in the SSQ for this model is a result of the increased number of parameters. (B) Best fit results of the concentration dependent TTR reassembly to a variant of Mechanism E with a conformational change after dimerization ($MD'DRT$). The table indicates the sum of squared differences (SSQ) and the best fit rate constants with the units of $\mu M^{-1} sec^{-1}$ for all bimolecular processes and with the units of sec^{-1} for all first-order rate processes. As above, the slight improvement in the SSQ for this model is a result of the increased number of parameters. Fitting to a variant of the Mechanism E pathway with a conformational change in the trimer ($MDR'RT$) or the tetramer ($MDRT'T$) did not improve the SSQ value as compared to Mechanism E. (C) Fitting analysis of the concentration dependent TTR reassembly to a variation of the Mechanism E pathway with a second dimerization pathway (MD_1D_2RT). The table indicates the sum of squares value (SSQ) and the fitted rate constants with the units of $\mu M^{-1} sec^{-1}$ for all bimolecular processes and with the units of sec^{-1} for all first-order rate processes.